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 Application No.	Applicant(s)	
10/694,221	CHEN ET AL.	
Examiner	Art Unit	
John E Chapman	2856	

SEARCHED			
Class	Subclass	Date	Examiner
73	514.36		
	514.37		
	514.38		
	514.32		
	514.21		
	514.23		
	514.24	10/18/2004	X

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
73	514.36		
	514.32	3/15/05	X
			5

SEARCH NOT (INCLUDING SEARCH	ES STRATEGY) .
	DATE	EXMR
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